

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q88662

Takenori OSADA, et al.

Appln. No.: 10/540,513

Group Art Unit: 2893

Confirmation No.: 6641

Examiner: Eduardo A. RODELA

Filed: June 23, 2005

For: COMPOUND SEMICONDUCTOR EPITAXIAL SUBSTRATE AND METHOD FOR  
MANUFACTURING THE SAME

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two months, extending the time for responding to the Office Action of April 23, 2009 to September 23, 2009.

The statutory fee of \$490.00 is being charged to Deposit Account No. 194880 via EFS Payment Screen. The USPTO is authorized and directed to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

/ Travis B. Ribar /

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**23373**

CUSTOMER NUMBER

Date: September 22, 2009